






HYDROPHOBICALLY COATED PRESSURE SENSOR**Patent number:** WO03054499**Publication date:** 2003-07-03**Inventor:** HEGNER FRANK (DE); DREWES ULFERT (DE);
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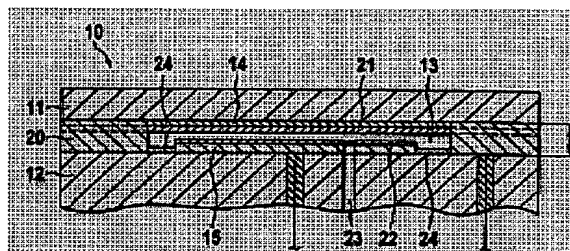
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The invention relates to a pressure sensor for measuring a measuring pressure. The inventive pressure sensor comprises a pressure compartment and a deformation body that can be impinged upon with a medium that is subject to the measuring pressure and that at least partially delimits the pressure compartment and closes the latter from the medium in a pressure-sealed manner. The walls of the sensor compartment comprise a hydrophobic coating that is applied by chemical vapor deposition. The hydrophobic coating preferably comprises silanes, especially silanes having one or more hydrophobic groups R and one or more anchoring groups X. Particularly preferred are the groups R-Si-X₃, R₁R₂-Si-X₂, R₁R₂R₃-Si-X. The hydrophobic group is preferably an alkyl, perfluoroalkyl, phenyl or perfluorophenyl group. The anchoring group X is preferably OH (silanol), -X (halogenide, e.g. Cl), -OR (ester, e.g. OCH₃), -NH₂ (amine) or SH (mercaptosilane). Aliphatic or cyclic silazanes Si-NH-Si, e.g. hexamethyldisilazane, can also be used. Compounds of the Ry-Me-XZ with Me = e.g. Zr, Ti, can also be used.



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